



MIT9922

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**APPLICANT:** Menon et al.      **GROUP:** 2881  
**SERIAL NO:** 10/624,316      **EXAMINER:** Berman, Jack I.  
**FILED:** 07/21/2003  
**FOR:** SYSTEM AND METHOD FOR MASKLESS LITHOGRAPHY USING  
AN ARRAY OF IMPROVED DIFFRACTIVE FOCUSING ELEMENT

**Mail Stop Non-Fee Amendment**  
**Assistant Commissioner of Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22313-1450**

**Sir:**

**AMENDMENT**

Responsive to the Office Action mailed on July 14, 2004, please amend the above-identified application as follows: